INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 24, 2026

IGI Report Number	LG849637291
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	9.10 X 6.09 X 4.01 MM

GRADING RESULTS

Carat Weight	1.96 CARAT
Color Grade	G
Clarity Grade	VS 1

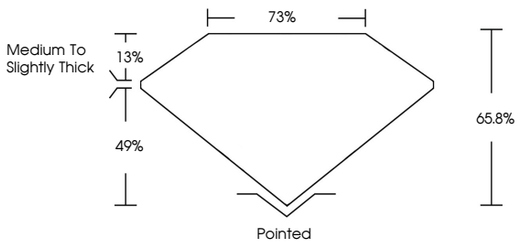
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG849637291

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG849637291
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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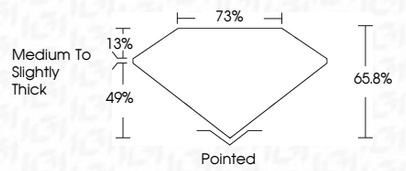
www.igi.org

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CUT CORNERED RECT. MODIFIED BRILLIANT
9.10 X 6.09 X 4.01 MM
Carat Weight 1.96 CARAT
Color Grade G
Clarity Grade VS 1
Depth 65.8%
Table 73%
Girdle Medium To Slightly Thick
Culet Pointed
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG849637291
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